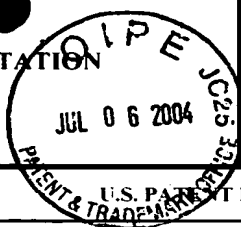


# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



Docket Number (Optional)

FJ-2000-041-US

Application Number

09/784,159

Applicant(s)

Hiroshi Tanaka, et al.

Filing Date

February 16, 2001

Group Art Unit

2615

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

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## U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		9-135412	05/20/1997	Japan			ABS	
		PCT WO96/007271	03/07/1996	WIPO				✓

## OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

		Japanese Office Action dated April 13, 2004 with English Translation.

EXAMINER

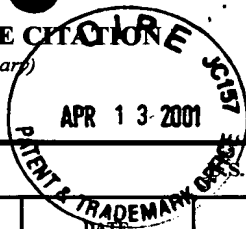
*[Handwritten signature]*

DATE CONSIDERED

12/1/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

# **INFORMATION DISCLOSURE CITATION** (Use several sheets if necessary)



Docket Number (Optional) <b>FJ-2000-041-US</b>	Application Number <b>09/784,159</b>
Applicant(s) <b>Tanaka et al.</b>	
Filing Date <b>February 16, 2001</b>	Group Art Unit <b>Unknown</b>

## **U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

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**AUG 06 2001**  
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## **FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		<b>10-215397</b>	<b>08/11/98</b>	<b>JAPAN</b>			<b>ABS</b>	
		<b>10-308981</b>	<b>11/17/98</b>	<b>JAPAN</b>			<b>ABS</b>	

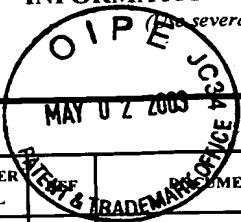
## **OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER 	DATE CONSIDERED <b>12/1/04</b>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

# INFORMATION DISCLOSURE CITATION

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Docket Number (Optional)

FJ-2000-041-0

Application Number

09/784,159

Applicant(s)

Hiroshi Tanaka, et al.

Filing Date

February 16, 2001

Group Art Unit

2615-26/2

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	5,313,572	05/17/1994	Yamamoto et al.	395	145	
	5,943,603	08/24/1999	Parulski et al.	455	3.1	

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## FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	JP 11-261717	09/24/1999	Japan			ABS	
	EP 0 883 282	12/09/1998	Europe			✓	
	JP 2001-111712	04/20/2001	Japan			ABS	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

European Search Report dated April 2, 2003.

EXAMINER

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